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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Shin Ohnuki

Serial No.: 10/796,344

Conf. No.: 1978

Filed: 3/9/2004

For: VACUUM PROCESSING  
APPARATUS

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Examiner: Lund, Jeffrie Robert

) I hereby certify that this paper is being deposited with the  
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) Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on  
) this date.

) 10/31/07

) Date

) F-CLASS WCM

) Appr. February 20, 1998

*Joseph P. Jr.*

Registration No. 41,760

Attorney for Applicant(s)

**AMENDMENT D**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action mailed October 10, 2007, please  
amend the application as follows: